	Туре	L	#	Hits	Search Text	DBs	Time Sta	ump
1	IS&R	L1		8	((427/8,10,569-579,562-564) or (216/67) or (118/723R,665,688-691)).CC LS.	i	2004/09/ 08:55	20
2	BRS	L2		1770			2004/09/ 08:58	20
3	BRS	L3	4	430	radiat\$5 laser)with(measur\$5 detect\$5 test\$4)same(plasma corona		2004/09/2 08:59	2 0

EAST Search update 10/075,244

	Туре	L	# Hits		DBs	Time Stam
1	IS&R	L1	41	(("6576559") or ("6613588") or ("6712928") or ("6778272") or ("6386949") or ("6153444") or ("6355570") or ("5578844") or ("6576559") or ("6721047") or ("6556290") or ("6667806") or ("6621571") or ("6800859") or ("5989928") or ("5656811") or ("53333495") or ("5214282") or ("5046847") or ("4777374")).PN.	USPAT; US-PGPUE; FPO; JPO; DERWENT; IBM_TDB	2004/09/1 ²
2	BRS	L2	13	1 and (plasma corona (glow electric)adj dischar\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/17 16:34
3	BRS	L3	31	1 and (light photo spectroscop\$3 irradiat\$5 radiat\$5 laser)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/17 16:36
4	BRS	L4	12	2 and 3		2004/09/17 16:36

EAST Review of Inventor Name Seach results 10/075,244



Day: Friday Date: 9/17/2004

Time: 15:36:53

Inventor Name Search Result

Your Search was:

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For SN10/075,244 (No childern or parents

Last Name = NAKANO First Name = HIROYUKI

	# Patent#	Status	Date Filed	Title	Inventor Name 51
10897203	Not Issued	019		HIGH FREQUENCY SWITCH AND ELECTRONIC DEVICE INCLUDING THE SAME	NAKANO, HIROYUKI
10859167	Not Issued	020		OPTICAL AMPLIFIER	NAKANO, HIROYUKI
10859084	Not Issued	030	06/03/2004	WIPIER BLADE HAVING LEVER CONNECTED TO WIPER ARM	NAKANO, HIROYUKI
10790180	Not Issued	020	03/02/2004	METHOD OF DETECTING PARTICLES AND A PROCESSING APPARATUS USING THE SAME	NAKANO, HIROYUKI
10777656	Not Issued	030	02/13/2004	OPTICAL TRANSMISSION SYSTEM CONSTRUCTING METHOD AND SYSTEM	NAKANO, HIROYUKI
10740627	Not Issued	030	12/22/2003	SURFACE LIGHT SOURCE DEVICE	NAKANO, HIROYUKI
10727665	Not Issued	093		OPTICAL AMPLIFIER, OPTICAL TRANSMISSION EQUIPMENT, OPTICAL TRANSMISSION SYSTEM, AND METHOD THEREOF	NAKANO, HIROYUKI
10667656	Not Issued	030	09/23/2003	DISHWASHER	NAKANO, HIROYUKI
10667424	Not Issued			DISHWASHER	NAKANO, HIROYUKI
10654810	Not Issued	093			NAKANO, HIROYUKI
10601799	Not Issued	030	/		NAKANO, HIROYUKI

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X	10467385	Not Issued	030	07/28/200	3 EXPOSURE METHOD AND EXPOSURE APPARATUS USING COMPLEMENTARY DIVISION MASK, AND SEMICONDUCTOR DEVICE AND METHOD FOR MAKING THE SAME	NAKANO, HIROYUKI
A	10445944	6747792	150	05/28/2003	OPTICAL AMPLIFYING METHOD	NAKANO, HIROYUKI
	10376274 1- Fapp 8-14-Med	Iggued	041	03/03/200	PARTICLE CONTROL DEVICE AND PARTICLE CONTROL METHOD FOR VACUUM PROCESSING APPARATUS	NAKANO, HIROYUKI
V	10316210	Not Issued	092	12/10/2002	ELECTRODE FORMING METHOD AND FIELD EFFECT TRANSISTOR	NAKANO, HIROYUKI
A	10300194	6737921	150	11/20/2002	DISTRIBUTED AMPLIFIER AND DIFFERENTIAL DISTRIBUTED AMPLIFIER	NAKANO, HIROYUKI
A	10270648	6577439	150	10/16/2002	OPTICAL AMPLIFIER	NAKANO, HIROYUKI
	<u>10270505</u>	6671431	150	10/16/2002	OPTICAL TRANSMISSION DEVICE AND OPTICAL TRANSMISSION SYSTEM EMPLOYING THE SAME	NAKANO, HIROYUKI
7	<u>10242600</u>	6674938	150		OPTICAL AMPLIFIER, OPTICAL TRANSMISSION EQUIPMENT, OPTICAL TRANSMISSION SYSTEM, AND METHOD THEREOF	NAKANO, HIROYUKI
4	10232441	Not Issued	095	08/29/2002	LIQUID CRYSTAL DISPLAY DEVICE	NAKANO, HIROYUKI
rech rech	10231267	Not Issued	094	08/30/2002	SEMICONDUCTOR DEVICE PROCESSING METHOD AND PLASMA PROCESSING METHOD AND ITS APPARATUS	NAKANO, HIROYUKI
A	<u>10207896</u>	<u>6708899</u>	150	07/31/2002	HEADLAMP CLEANER & INJECTION CONTROL METHOD	NAKANO, HIROYUKI
X		6658761	150		METHOD AND APPARATUS FOR CENTRIFUGALLY DEHYDRATING WORKPIECE	NAKANO, HIROYUKI
A	10199038	Not Issued	030	07/22/2002) () OLYD THE THE	NAKANO, HIROYUKI

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	10197826	Not Issued	161 1011	07/19/2002	HETEROJUNCTION FIELD EFFECT TRANSISTOR AND MANUFACTURING METHOD THEREFOR	NAKANO, HIROYUKI
	10095066	6576559	150	03/12/2002	SEMICONDUCTOR MANUFACTURING METHODS, PLASMA PROCESSING METHODS AND PLASMA PROCESSING APPARATUSES	NAKANO, HIROYUKI
Love	10075244	Not Issued	071	02/15/2002	METHOD AND APPARATUS FOR PLASMA PROCESSING	NAKANO, HIROYUKI
4	<u>09988696</u>	6496617	150	11/20/2001	OPTICAL AMPLIFIER, OPTICAL TRANSMISSION EQUIPMENT, OPTICAL TRANSMISSION SYSTEM, AND METHOD THEREOF	NAKANO, HIROYUKI
A	<u>09954012</u>	6490387	150	09/18/2001	OPTICAL TRANSMISSION DEVICE AND OPTICAL TRANSMISSION SYSTEM EMPLOYING THE SAME	NAKANO, HIROYUKI
	09933185 (6613588)150		FLOATING PARTICLE INSPECTION METHOD AND ITS APPARATUS AND A SEMICONDUCTOR DEVICE PROCESSING APPARATUS	NAKANO, HIROYUKI
A	<u>09907939</u>	6728489	150	1	OPTICAL TRANSMISSION SYSTEM CONSTRUCTING METHOD AND SYSTEM	NAKANO, HIROYUKI
A	09824572	6726825	150		METHOD AND APPARATUS FOR MANUFACTURING POSITIVE ELECTRODE FOIL OF ALUMINUM ELECTROLYTIC CAPACITOR	NAKANO, HIROYUKI
	09791677	6712928	150		METHOD AND ITS APPARATUS FOR DETECTING FLOATING PARTICLES IN A PLASMA PROCESSING CHAMBER AND AN APPARATUS FOR PROCESSING A SEMICONDUCTOR DEVICE	NAKANO, HIROYUKI
P	09763735	Not Issued	030	09/17/2001	CIRCUIT BOARD	NAKANO, HIROYUKI
?		5778272	150			NAKANO, HIROYUKI
	09759164	5545732	150	01/16/2001	BACKLIGHT ASSEMBLY FOR	NAKANO,

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					LIQUID CRYSTAL DISPLAY DEVICE	HIROYUKI
4	09748012	Not Issued	041	12/27/2000	FIXING ROLLER	NAKANO, HIROYUKI
4	09663378	6314217	150	09/15/2000	OPTICAL TRANSMISSION DEVICE AND OPTICAL TRANSMISSION SYSTEM EMPLOYING THE SAME	NAKANO, HIROYUKI
A	<u>09662872</u>	6321002	150	09/15/2000	OPTICAL AMPLIFIER, OPTICAL TRANSMISSION EQUIPMENT, OPTICAL TRANSMISSION SYSTEM, AND METHOD THEREOF	NAKANO, HIROYUKI
1	09647533	6403607	150	10/02/2000	SULFONAMIDE DERIVATIVES AND DRUGS CONTAINING THE SAME AS THE ACTIVE INGREDIENT	NAKANO, HIROYUKI
A	09585280	6542290	150	06/02/2000	OPTICAL AMPLFIER	NAKANO, HIROYUKI
A	09571357	6336539	150	05/15/2000	DRAIN MECHANISM FOR HYDRAULIC POWER TRANSMISSION JOINT	NAKANO, HIROYUKI
A	<u>09571356</u>	6454070	150	05/15/2000	DRAIN MECHANISM FOR HYDRAULIC POWER TRANSMISSION JOINT	NAKANO, HIROYUKI
P	<u>09553016</u>	6283264	150	04/20/2000	HYDRAULIC POWER TRANSMISSION JOINT	NAKANO, HIROYUKI
7	09527532 (6386949		7	METHOD FOR CLEANSING/SCRAPING AND APPARATUS THEREFOR	NAKANO, HIROYUKI
A	09352164	6262402	150			NAKANO, HIROYUKI
A	<u>09351463</u>	6252211	150	II II	l	NAKANO, HIROYUKI
7	08921829	6153444	1)50			NAKANO , HIROYUKI

08052823	Not Issued	161 Wod		NAKANO , HIROYUKI
07514594	4984539	150	04/26/1990	NAKANO , HIROYUKI
<u>06651869</u>	4649364	150	09/18/1984	NAKANO , HIROYUKI

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Inventor Name Search Result

Your Search was:

Last Name = NAKANO First Name = HIROYUKI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 51
09409872	6266169	150	10/01/1999	OPTICAL TRANSMISSION EQUIPMENT WHICH TRANSMITS AN AMPLIFIED OPTICAL DATA SIGNAL AND AN OPTICAL SURVEILLANCE SIGNAL	NAKANO , HIROYUKI
09352163	6184508	150	07/12/1999	APPARATUS FOR JOINING METAL PIECES USING INDUCTION HEATING	NAKANO , HIROYUKI
09352157	6218649	150	07/12/1999	METHOD AND APPARATUS FOR JOINING METAL PIECES USING INDUCTION HEATING	NAKANO , HIROYUKI
09351372	6248984	150	07/12/1999	METHOD AND APPARATUS FOR JOINING METAL PIECES	NAKANO , HIROYUKI
09262344	6229936	150	03/04/1999	OPTICAL AMPLILFIER, OPTICAL TRANSMISSION EQUIPMENT, OPTICAL TRANSMISSION SYSTEM, AND METHOD THEREOF	NAKANO , HIROYUKI
09260074	6355570)150		SEMICONDUCTOR MANUFACTURING METHODS, PLASMA PROCESSING METHODS AND PLASMA PROCESSING APPARATUSES	NAKANO , HIROYUKI
99247925	Not Issued	161 Ma	ļ	OPTICAL TRANSMISSION SYSTEM AND METHOD OF SUPERVISING THE SAME	NAKANO , HIROYUKI
<u>09244856</u>	6018405	150		OPTICAL TRANSMISSION EQUIPMENT WHICH TRANSMITS AN AMPLIFIED OPTICAL DATA SIGNAL AND AN OPTICAL SURVEILLANCE	NAKANO , HIROYUKI

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		<u> </u>	<u> </u>	SIGNAL	
09231780	Not Issued	old old		OPTICAL TRANSMISSION SYSTEM, END TERMINAL AND OPTICAL REPEATER	NAKANO , HIROYUKI
09129844	6195480	150	08/06/1998	OPTICAL TRANSMISSION DEVICE AND OPTICAL TRANSMISSION SYSTEM EMPLOYING THE SAME	NAKANO, HIROYUKI
09069772	6091540	150	04/30/1998	OPTICAL AMPLIFIER	NAKANO , HIROYUKI
08927277	6005699	150	09/11/1997	OPTICAL WAVELENGTH MULTIPLEXING SYSTEM	NAKANO , HIROYUKI
08906296	5864424	150	08/05/1997	OPTICAL SIGNAL AMPLIFYING CIRCUIT	NAKANO , HIROYUKI
08855470	5749996	150	05/13/1997	METHOD OF PRODUCING RECLAIMED JOINT SHEET AND THE RECLAIMED JOINTSHEET	NAKANO , HIROYUKI
<u>08746027</u>	<u>5875046</u>	150		OPTICAL REPEALER AND OPTICAL TRANSMITTER	NAKANO , HIROYUKI
08744492	5861972	150	11/06/1996	OPTICAL MULTIPLEX TRANSMISSION EQUIPMENT AND METHOD	NAKANO , HIROYUKI
08705366	5812289	150		OPTICAL REPEATER AND OPTICAL TRANSMITTER	NAKANO , HIROYUKI
08688240	Not Issued	161/		OPTICAL AMPLIFIER, OPTICAL TRANSMITTER, OPTICAL RECEIVER, THEIR CONTROL METHOD AND METHOD OF TRANSFERRING SUPERVISORY SIGNAL	NAKANO , HIROYUKI
<u>08667214</u>	5739932	150		OPTICAL TRANSMISSION SYSTEM CONSTRUCTING METHOD AND SYSTEM	NAKANO , HIROYUKI
08667213	5671074	150		OPTICAL MULTIPLEX TRANSMISSION EQUIPMENT AND METHOD	NAKANO , HIROYUKI
08666845	5706125	150	I II	OPTICAL SIGNAL AMPLIFYING CIRCUIT	NAKANO , HIROYUKI
08556426	5670297			PROCESS FOR THE FORMATION OF A METAL PATTERN	NAKANO , HIROYUKI
08528432	<u>5712632</u>	250		NAVIGATION APPARATUS FOR LAND VEHICLE INPUTTING ROAD TRAFFIC	NAKANO , HIROYUKI

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\mathcal{L}	08513789	5951903	150	12/20/1005	INFORMATION METHOD AND APPARATUS	NAKANO
17	90013702	3731703			FOR JOINING METAL PIECES	NAKANO , HIROYUKI
,	08454958	5627090	150	05/31/1995	SEMICONDUCTOR ELEMENT AND PROCESS FOR PRODUCTION FOR THE SAME	NAKANO , HIROYUKI
	08452142	5658657	150	05/26/1995	RECLAIMED JOINT SHEET	NAKANO , HIROYUKI
\downarrow	08432074	5831754	150		OPTICAL AMPLIFIER	NAKANO , HIROYUKI
,	08328298	Not Issued	166/	10/24/1994	OPTICAL AMPLIFIER, OPTICAL TRANSMITTER, OPTICAL RECEIVER, THEIR CONTROL METHOD AND METHOD OF TRANSFERRING SUPERVISORY SIGNAL	NAKANO , HIROYUKI
4		5614800	150		METHOD AND APPARATUS FOR PREPARING NUMERICAL CONTROL DATA	NAKANO , HIROYUKI
`	08301961	Not Issued	166	09/07/1994	SEMICONDUCTOR ELEMENT AND PROCESS FOR PRODUCTION FOR THE SAME	NAKANO , HIROYUKI
A	08044425	5555477	150		OPTICAL TRANSMISSION SYSTEM CONSTRUCTING METHOD AND SYSTEM	NAKANO , HIROYUKI
4	08023546	<u>5500756</u>	150			NAKANO , HIROYUKI
\mathcal{A}	08017433	<u>5363598</u>	150		MACHINE TOOL CAPABLE OF GRINDING A WORKPIECE WITH A TRUING APPARATUS	NAKANO , HIROYUKI
	07757067	Not Issued	166/	i i	MACHINE TOOL CAPABLE OF GRINDING A WORKPIECE WITH A TRUING APPARATUS	NAKANO , HIROYUKI
4		5292579			METHOD OF MANUFACTURING THEREOF	NAKANO , HIROYUKI
	07656512	5110630	150	[]]		NAKANO , HIROYUKI
	J	11	II	il.		

<u> </u>	Not Issued	161/ all) 11/02/1990	METHOD OF CONTROLLING INPUT AND OUTPUT SIGNALS	NAKANO, HIROYUKI
07599603	5015670	150	10/18/1990	POLYCARBONATE RESIN COMPOSITION	NAKANO, HIROYUKI
07581775	5085184	150	09/13/1990	DEVICE FOR REDUCING STARTING LOAD ON INTERNAL COMBUSTION ENGINE	NAKANO , HIROYUKI
07386219	5130203			METAL GASKET AND METHOD OF PRODUCING THE SAME	NAKANO, HIROYUKI
07352470	<u>4919575</u>	150	05/16/1989	APPARATUS FOR COMPENSATING FOR THE THERMAL DISPLACEMENT OF THE MAIN SPINDLE OF A MACHINE TOOL	NAKANO , HIROYUKI
07342964	4978406	150	04/25/1989	PROCESS FOR PRODUCING TUBE	NAKANO , HIROYUKI
07326430	4945324	150	03/17/1989	THIN FILM FERROMAGNETIC RESONANCE TUNED FILTER	
07281289	4873496	150	12/08/1988	TUNED OSCILLATOR	NAKANO, HIROYUKI
07276146	<u>4887052</u>	150	11/25/1988	TUNED OSCILLATOR UTILIZING THIN FILM FERROMAGNETIC RESONATOR	NAKANO , HIROYUKI
07127014	Not Issued				NAKANO , HIROYUKI
07117958	4905040	150	11/09/1987	BOARD COPYING APPARATUS	NAKANO , HIROYUKI
07109741	<u>4847579</u>	150			NAKANO , HIROYUKI
06745832	<u>4661519</u>	150			NAKANO , HIROYUKI
	4649364	150			NAKANO , HIROYUKI
0648/270	Not Issued	166]	COMPOSITION FOR	NAKANO , HIROYUKI

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Application#	Patent#	Status	Date Filed	Title	Inventor Name 2
08607817	5578844	150		SEMICONDUCTOR ELEMENT AND PROCESS FOR PRODUCTION FOR THE SAME	NAKANO , HIROYUKI
06484270	Not Issued	166 JM		COMPOSITION FOR DERMATOLOGICAL APPLICATION	NAKANO , HIROYUKI

Inventor Search Completed: No Records to Display.

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NAKANO HIROYUKI Search

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Inventor Name Search Result

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Last Name = NAKATA First Name = TOSHIHIKO

Application#||Patent#||Status||Date Filed||Title **Inventor Name 47** 10888980 Not 020 07/13/2004 ULTRAVIOLET LASER-NAKATA. Issued GENERATING DEVICE AND TOSHIHIKO DEFECT INSPECTION APPARATUS AND METHOD THEREFOR 10790180 03/02/2004||METHOD OF DETECTING Not 020 NAKATA, Issued PARTICLES AND A TOSHIHIKO PROCESSING APPARATUS USING THE SAME 10628421 Not 020 |07/29/2003||DISPLAY DEVICE, PROCESS NAKATA. Issued OF FABRICATING SAME. TOSHIHIKO AND APPARATUS FOR FABRICATING SAME 10340517 Not 041 01/09/2003 SCANNING PROBE NAKATA, Issued MICROSCOPE AND TOSHIHIKO SPECIMEN OBSERVATION line METHOD AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD USING SAID SCANNING PROBE MICROSCOPE 10295909 Not 092 11/18/2002 DEFECT INSPECTION NAKATA, Issued METHOD AND APPARATUS TOSHIHIKO Np THEREFOR 10267680 071 10/10/2002||LASER ANNEALING Not NAKATA, Issued APPARATUS, TFT DEVICE TOSHIHIKO AND ANNEALING METHOD OF THE SAME |09/06/2002||APPARATUS AND METHOD 10235656 Not 030 NAKATA, Issued FOR MEASURING TOSHIHIKO ALÌGNMENT ACCURACY, AS WELL AS METHOD AND SYSTEM FOR-MANUFACTURING

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					SEMICONDUCTOR DEVICE		
	10231267	Not Issued	094	08/30/2002	SEMICONDUCTOR DEVICE PROCESSING METHOD AND PLASMA PROCESSING METHOD AND ITS APPARATUS		
	10223423	Not Issued	030	08/20/2002	METHOD AND APPARATUS FOR DETECTING PATTERN DEFECTS	NAKATA, TOSHIHIKO	
	10223422	Not Issued	030	08/20/2002	METHOD AND APPARATUS FOR INSPECTING PATTERN DEFECTS	NAKATA, TOSHIHIKO	
/	10095066(6576559)150		SEMICONDUCTOR MANUFACTURING METHODS, PLASMA PROCESSING METHODS AND PLASMA PROCESSING APPARATUSES	NAKATA, TOSHIHIKO	
	10075244	Not Issued	071	02/15/2002	METHOD AND APPARATUS FOR PLASMA PROCESSING	NAKATA, TOSHIHIKO	
	10050778	Not Issued	094		APPARATUS AND METHOD FOR INSPECTING PATTERN	NAKATA, NOT TOSHIHIKO FFW	
	<u>09944858</u>	(721047)	150	08/31/2001	METHOD AND APPARATUS FOR INSPECTING DEFECTS OF A SPECIMEN	NAKATA, TOSHIHIKO	
	09933185	6613588	150	08/21/2001	FLOATING PARTICLE INSPECTION METHOD AND ITS APPARATUS AND A SEMICONDUCTOR DEVICE PROCESSING APPARATUS	NAKATA, TOSHIHIKO	
	<u>09797597</u> (6556290	<i>1</i> /50		DEFECT INSPECTION METHOD AND APPARATUS THEREFOR	NAKATA, TOSHIHIKO	
	09796613	6667806)150		PROCESS AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE	NAKATA, TOSHIHIKO	
	09791677	6712928	150		METHOD AND ITS APPARATUS FOR DETECTING FLOATING PARTICLES IN A PLASMA PROCESSING CHAMBER AND AN APPARATUS FOR PROCESSING A SEMICONDUCTOR DEVICE	NAKATA, TOSHIHIKO	
	09778776	6631547	150		A MANUFACTURING METHOD FOR THIN FILM	NAKATA, TOSHIHIKO	

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					MAGNETIC HEADS	
	<u>09764457</u>	6765201	150	01/19/2001	ULTRAVIOLET LASER- GENERATING DEVICE AND DEFECT INSPECTION APPARATUS AND METHOD THEREFOR	NAKATA, TOSHIHIKO
	09763735	Not Issued	030	09/17/2001	CIRCUIT BOARD PRODUCTION METHOD AND ITS APPARATUS	NAKATA, TOSHIHIKO
,	09760704	6778272	150	01/17/2001	METHOD OF PROCESSING A SEMICONDUCTOR DEVICE	NAKATA, TOSHIHIKO
	09698167	6621571	150	10/30/2000	METHOD AND APPARATUS FOR INSPECTING DEFECTS IN A PATTERNED SPECIMEN	NAKATA, TOSHIHIKO
	<u>09678652</u>	Not Issued	071	10/04/2000	METHOD OF INSPECTING A DNA CHIP AND AN APPARATUS THEREOF	NAKATA, TOSHIHIKO
	09473296	6800859)50	12/28/1999	METHOD AND EQUIPMENT FOR DETECTING PATTERN DEFECT	NAKATA, TOSHIHIKO
`	09437265	Not Issued	094	11/10/1999	METHOD FOR MEASURING DIMENSIONS AND ALIGNMENT OF THIN FILM MAGNETIC HEAD AND APPARATUS THEREFOR	NAKATA , TOSHIHIKO
,	09260074	6355570	150		SEMICONDUCTOR MANUFACTURING METHODS, PLASMA PROCESSING METHODS AND PLASMA PROCESSING APPARATUSES	NAKATA , TOSHIHIKO
	<u>09051767</u>	5989928)50		METHOD AND DEVICE FOR DETECTING END POINT OF PLASMA TREATMENT, METHOD AND DEVICE FOR MANUFACTURING SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE	NAKATA , TOSHIHIKO
	08548015	5781294	150	NO 5	METHOD AND APPARATUS FOR DETECTING PHOTOACOUSTIC SIGNAL TO DETECT SURFACE AND SUBSURFACE INFORMATION OF THE SPECIMEN	NAKATA , TOSHIHIKO
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	08490423	5656811	150	06/14/1995	METHOD FOR MAKING SPECIMEN AND APPARATUS THEREOF	NAKATA , TOSHIHIKO
NO	08364777	5645351		12/27/1994	TEMPERATURE MEASURING METHOD USING THERMAL EXPANSION AND AN APPARATUS FOR CARRYING OUT THE SAME	TOSHIHIKO
	08012758	5333495		03/11/1993	METHOD AND APPARATUS FOR PROCESSING A MINUTE PORTION OF A SPECIMEN	NAKATA , TOSHIHIKO
M	07994150	5479259	150	12/21/1992	METHOD AND APPARATUS FOR DETECTING PHOTOACOUSTIC SIGNAL	NAKATA , TOSHIHIKO
po	07886014	5377006		05/20/1992	METHOD AND APPARATUS FOR DETECTING PHOTOACOUSTIC SIGNAL	NAKATA , TOSHIHIKO
1	07707774	5214282	150	05/30/1991	METHOD AND APPARATUS FOR PROCESSING A MINUTE PORTION OF A SPECIMEN	NAKATA , TOSHIHIKO
W	07567319	5136172			METHOD AND APPARATUS FOR DETECTING PHOTOACOUSTIC SIGNAL	NAKATA , TOSHIHIKO
VV)	<u>07479712</u>	5062715	150		METHOD AND APPARATUS FOR DETECTING PHOTOACOUSTIC SIGNAL AND METHOD FOR DETECTING INTERNAL DEFECT OF SEMICONDUCTOR DEVICE	NAKATA , TOSHIHIKO
\mathcal{M}	07384541	5083869	150	07/24/1989	PHOTOACOUSTIC SIGNAL DETECTING DEVICE	NAKATA , TOSHIHIKO
\mathcal{M}	07305006	4906852			METHOD AND APPARATUS	NAKATA , TOSHIHIKO
	07262573(5046847	¥50		METHOD FOR DETECTING FOREIGN MATTER AND DEVICE FOR REALIZING SAME	NAKATA , TOSHIHIKO
ND	<u>07142698</u>	4788577	150		SUBSTRATE SURFACE DEFLECTING DEVICE	NAKATA , TOSHIHIKO
J ⁷		4795261			TYPE ALIGNER	NAKATA , TOSHIHIKO
90	06886044	4744666	150			NAKATA , TOSHIHIKO

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	06868601	4777374)150	05/30/1986	PATTERN POSITION DETECTING METHOD AND APPARATUS FAR DETECTING THE POSITION OF AN ALIGNMENT DIRECTION OF A WAFER TARGET PATTERN	NAKATA , TOSHIHIKO
lb	06797131	4725737	150		ALIGNMENT METHOD AND APPARATUS FOR REDUCTION PROJECTION TYPE ALIGNER	NAKATA , TOSHIHIKO
)	06762329	4701050	150	08/05/1985	SEMICONDUCTOR EXPOSURE APPARATUS AND ALIGNMENT METHOD THEREFOR	NAKATA , TOSHIHIKO
)	<u>06684292</u>	4668089	150		EXPOSURE APPARATUS AND METHOD OF ALIGNING EXPOSURE MASK WITH WORKPIECE	NAKATA , TOSHIHIKO

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